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	Application No.	Applicant(a)
	Application No.	Applicant(s)
Notice of Allowability	10/749,349 Examiner	PARK ET AL. Art Unit
	Examiner	Art Onit .
	Mike Stahl	2874
The MAILING DATE of this communication appear All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RI of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this app or other appropriate communication IGHTS. This application is subject to	plication. If not included will be mailed in due course. THIS
1. This communication is responsive to		
2. The allowed claim(s) is/are <u>1-8</u> .		
3. The drawings filed on 31 December 2003 are accepted by the Examiner.		
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	been received. been received in Application No	•
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONM THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		complying with the requirements
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner's Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the statement sheet (see 25 CFR 1). 	on's Patent Drawing Review (PTO- s Amendment / Comment or in the C .84(c)) should be written on the drawir	Office action of
7. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT		
 Attachment(s) 1. ☑ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 12/31/03 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material 	6. ☐ Interview Summary Paper No./Mail Dat 98), 7. ☑ Examiner's Amendr	e

Application/Control Number: 10/749,349

Art Unit: 2874

EXAMINER'S AMENDMENT

An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

The application has been amended as follows:

- Replace claim 1 with the following version:
- 1. A focusing waveguide grating coupler using a leaky mode, comprising:
 - a substrate having a first refractive index n1;
- a first core layer having a second refractive index n2, the first core layer being formed on the substrate;
- a second core layer having a third refractive index n3, the second core layer being formed on the first core layer apart from the first core layer with a space d in between;
- a first cladding layer having a fourth refractive index n4, the first cladding layer being formed on the second core layer;
- a second cladding layer having a fifth refractive index n5, the second cladding layer being formed on the first cladding layer and inserted between the first core layer and the second core layer; and
 - a Fresnel lens positioned on the second cladding layer,
- wherein the refractive indexes satisfy conditions of n5 >(n2, n3)>n1 and n5>n4; and light inputted through the first and second core layers propagates to the Fresnel lens

Application/Control Number: 10/749,349

Art Unit: 2874

as radiated leaky beams by a leaky mode formed according to the conditions, and the leaky beams form an optical focus by performing single directional coupling towards the lower part of the substrate by using beams reflected from the Fresnel lens.

The amendment to claim 1 includes the following changes. Every instance of "refraction index" was changed to "refractive index" in order to be more consistent with conventional terminology. "satisfies" was changed to "satisfy". "propagates" was inserted between "first and second core layers" and "to the Fresnel lens", and "refracted from the Fresnel lens" was changed to "reflected from the Fresnel lens". The latter two changes clarify the claim and are not regarded as altering its scope; support for those changes is found in the description at p. 13 lns. 11-16.

Allowable Subject Matter

Claims 1-8 are allowed. Claim 1 involves an improvement to a focusing waveguide grating coupler, in which the overall waveguide structure is configured to develop a leaky mode such that more of the input light reaches the Fresnel lens, which in turn enables more light to reach the focal point on the substrate side of the lens. The recited structure is not anticipated by or obvious in light of any of the references of record. The closest reference identified during the search is US 4861128, which discloses a pair of waveguide core layers and a focusing grating coupler. However, that reference differs from the claimed invention at least in that the Fresnel lens is positioned on the upper core layer rather than on a second cladding layer, and in that the light is not focused toward the lower part of the substrate. US 6436613 also discloses a multiple

Application/Control Number: 10/749,349 Page 4

Art Unit: 2874

layered waveguide with a grating coupler but the device does not meet all the structural and functional limitations of claim 1. Claims 2-8 are allowed by dependence from claim 1.

Conclusion

Inquiries about this letter should be directed to Mike Stahl at 571-272-2360. Inquiries of a general or clerical nature (e.g., a request for a missing form or paper, etc.) should be directed to the technical support staff supervisor at 571-272-1626. Official communications which are eligible for submission by facsimile and which pertain to this application may be faxed to 571-273-8300. Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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Art Unit 2874

August 18, 2005

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